



**ELECTRONIC COPY**

LG655426519  
Report verification at igi.org



October 1, 2024  
IGI Report Number **LG655426519**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **ROUND BRILLIANT**  
Measurements **8.57 - 8.62 X 5.15 MM**  
**GRADING RESULTS**  
Carat Weight **2.30 CARATS**  
Color Grade **E**  
Clarity Grade **VVS 2**  
Cut Grade **IDEAL**

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**GRADING RESULTS**

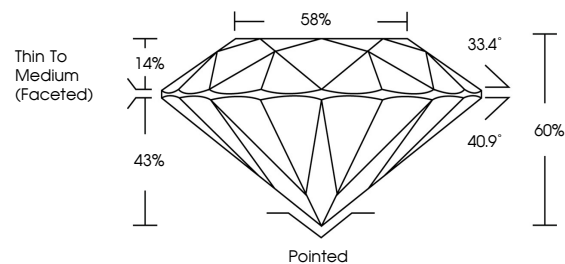
Carat Weight **2.30 CARATS**  
Color Grade **E**  
Clarity Grade **VVS 2**  
Cut Grade **IDEAL**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG655426519**

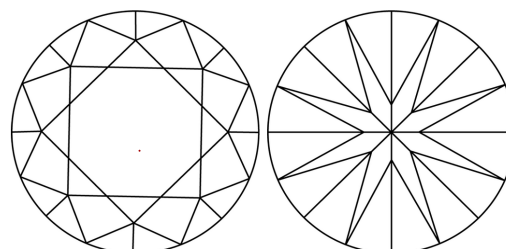
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

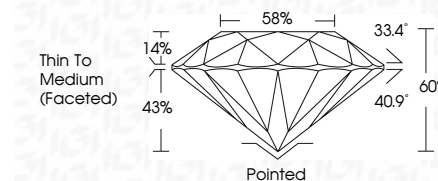
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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8.57 - 8.62 X 5.15 MM  
2.30 CARATS  
E  
VVS 2  
IDEAL  
E  
NONE  
IGI LG655426519

Thin To Medium (Faceted)  
Pointed  
EXCELLENT  
EXCELLENT  
NONE  
IGI LG655426519

Culet  
Polish  
Symmetry  
Fluorescence  
Inscriptions(s)

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